

IN THE SPECIFICATION

Please amend the Abstract of the Disclosure as follows:

ABSTRACT OF THE DISCLOSURE

Methods for producing micromachined layered devices ~~comprising~~ having a membrane layer and a first and second layer on both sides of the membrane layer are disclosed. ~~†~~ The method comprising includes: a) ~~applying~~ applying a membrane layer to a substrate; b) ~~opening~~ opening a window in the substrate so as to enable the addition of layers from both sides of the membrane layer while the substrate is made into a frame that supports the membrane layer during processing; c) ~~adding~~ adding at least one layer on each side of the membrane either simultaneously or on one side at a time; and d) ~~removing~~ removing the device from the substrate frame.